

SAMPLE CONDITIONING PACKAGE

PRODUCT DATA SHEET—203

Model 21— Inherently safe positive pressure driven sampler

For solvent-based processing

Introduction

The Neutronics Model 21 Sample Conditioning Package is designed to ensure that the oxygen sensor always has a clean, dry sample gas for accurate measurement. Process conditions that include solvents, corrosive chemicals, and temperature extremes present significant challenges. To deliver accurate and reliable gas measurement, sensors require a sample that is free of contaminants. Sample conditioning systems built to withstand harsh processing conditions and efficiently remove damaging contaminants from the sample stream are critical to delivering reliable continuous duty low-maintenance oxygen monitoring.

Operation

For the Model 21 Series Sample Conditioning Package, continuous positive pressure in the process vessel or system provides the force that pushes the sample gas from the process to the sensor. Suitable for applications with process operating pressures between 5 and 300 psig, the Model 21 Series sampler includes a pressure reducing regulator to control the pressure and flow of the sample gas through the system.

To provide the sensor with a continuous clean sample gas flow, many solvent based processes require the removal of varying amounts of entrained vapors. Designed for process temperatures at or slightly above ambient, the integral Neutronics vapor condenser removes solvent and water vapors from the sample gas stream before they can contaminate the sensor. It consists of a heat exchanger powered by a vortex cooler. The vortex cooler provides the refrigeration for the condenser assembly that is used to collect heat from the sample flow and condense entrained vapors. The vapor condenser is pneumatically powered. A vortex drive filter/regulator is included in the sample package to regulate the drive gas to 30 psig.

For processes with high operating temperatures, additional preconditioning components are typically included. The demister (Product Data Sheet 103) and the coalescing prefilter (Product Data Sheet 101) are frequently used to enhance liquid removal and filtration performance.

Available Options

NEMA 4 enclosure or panel-only mounting

Teflon wetted parts

Explosion proof heat tracing

Remote calibration valve

Single or dual oxygen sensors

Single or dual flammable or toxic gas sensors



Features

- Inherently safe design – with no moving parts, the pneumatically-powered Model 21 sampler is suitable for hazardous area locations
- Corrosion resistant NEMA 4X enclosure – suitable for indoor or outdoor use with protection against ingress of dust and water
- 316L pressure reducing regulator – controls the pressure and flow of the sample gas for applications with operating pressures up to 300 psig
- Integral flow switch – opens contacts in alarm when sample gas flow falls below a preset level
- Single or dual sensor compatible – option for redundant dual sensors enhances reliability
- Internal vapor condenser – high efficiency vortex cooler with no moving parts removes contaminants from the sample gas stream
- Low maintenance package – high quality components with few replacement parts minimizes maintenance costs and unplanned downtime

Applications

Process vessels

Reactors

Mixers

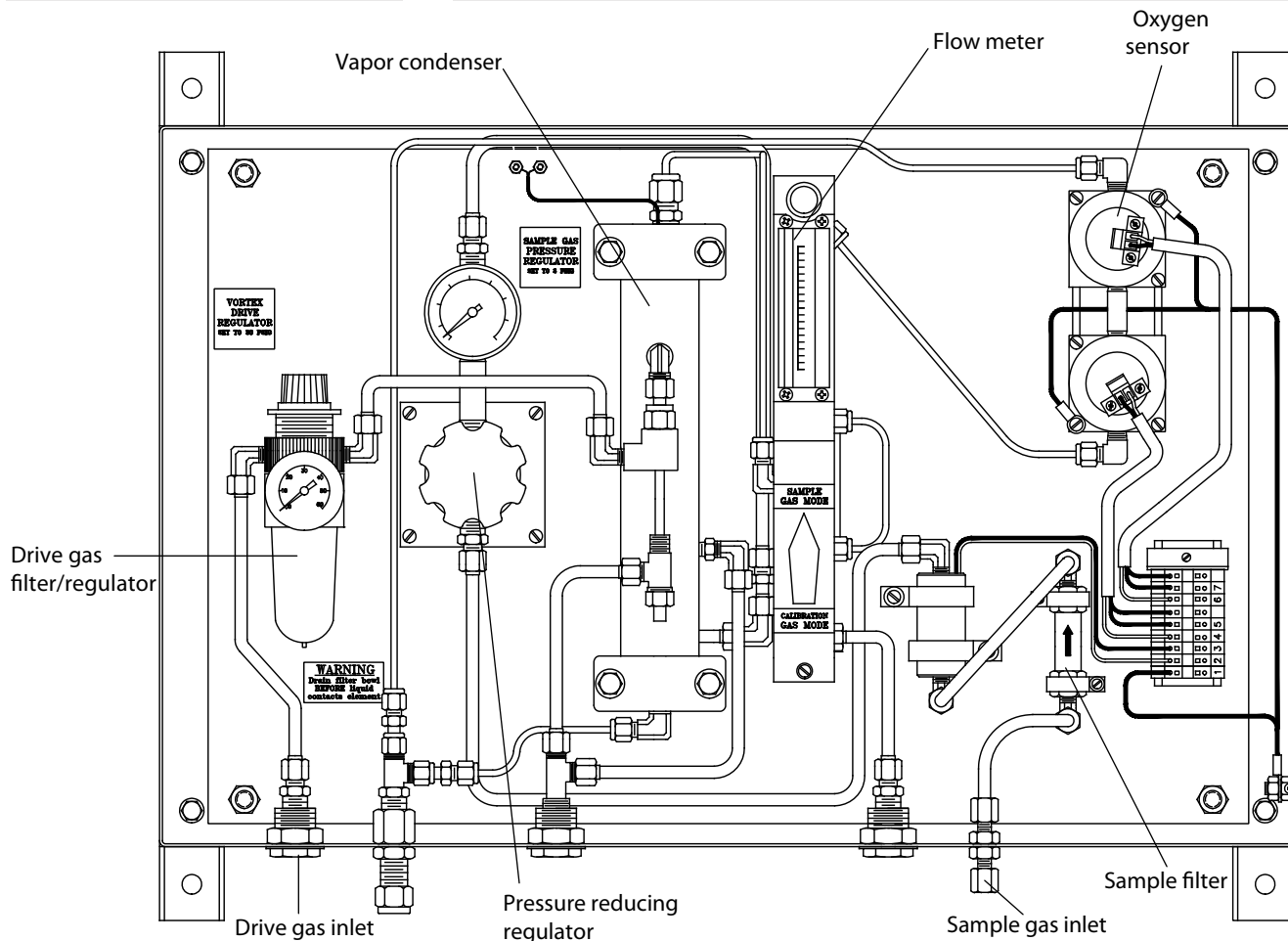
Dryers

Vent header monitoring

Solvent recovery systems

MODEL 21 SERIES SAMPLE CONDITIONING PACKAGE—SPECIFICATIONS

Sample gas pressure	5 to 300 psig
Sample gas flow	5 slpm (± 1 slpm) total flow
Venturi drive gas	Instrument quality air or nitrogen, 35 psig (min.) @ 2 scfm (± 0.5 scfm)
Sample filter	90 micron sintered metal, 316 SS
Sampling method	Positive pressure package with pressure reducing regulator, suitable for applications ranging from 5 to 300 psig
Vapor conditioning	Air-cooled vortex-driven vapor condenser with continuous drainage
Wetted materials	Stainless steel, glass, Teflon
Outside dimensions	23.62" (w) x 14.96" (h) x 8.6" (d) (600 x 380 x 211 mm)
Weight	50 lbs. (22.7 kg)

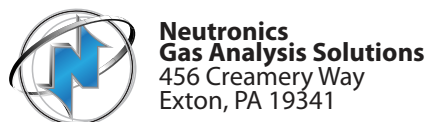


Spare parts

Part No. 4-05-2700-03-0	Drive gas filter regulator element
Part No. 4-05-2300-07-0	Sample gas particulate filter 90 micron

Order information

Part No. 7-04-2000-01-2	Model 21-609-123000-1	Single sensor, NEMA 4 enclosure
Part No. 7-04-2000-09-0	Model 21-609-123000-2	Single sensor, NEMA 4X enclosure
Part No. 7-04-2000-09-1	Model 21-609-123000-2UL	Single sensor, NEMA 4X enclosure, UL listed
Part No. 7-04-2000-12-0	Model 21-669-123000-2	Dual sensor, NEMA 4X enclosure
Part No. 7-04-2000-26-0	Model 21-669-123000-2UL	Dual sensor, NEMA 4X enclosure, UL listed



Tel: 610.524.8800
Fax: 610.524.8807
Email: info@neutronicsinc.com

www.analyzegas.com

